

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshiro YAMADA, et al.

Serial Number: Not Yet Assigned

(§371 of International Application PCT/JP03/09023)

Filed: January 14, 2005

For. METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS

FOR PRODUCING PERFLUORO-2-PENTYNE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

January 14, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

INFORMATION DISCLOSURE STATEMENT PTO-1449 Atty. Docket No. 050011

Serial No. New Application 272

Applicant(s): Toshiro YAMADA, et al.

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Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner ,Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
•	AA						
	AB						
	AC						
	AD						

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
AE	2000-206704	07/28/00	Japan	Cited in the International Search Report
 AF	2001-110790	04/20/01	Japan	Cited in the International Search Report
 AG	WO 00/30168 A	02/25/00	PCT	Cited in the International Search Report
 AH	2003-282540	10/03/03	Japan	Cited in the International Search Report
 AI	755909 A	01/29/97	EP	Cited in the International Search Report

OTHER DOCUMENTS

	AJ AK	
Examiner		Date Considered